

PCT Appl. No. PCT/JP2004/007609

**BOX PCT
IN THE UNITED STATES DESIGNATED/ELECTED OFFICE
OF THE UNITED STATES PATENT AND TRADEMARK OFFICE
UNDER THE PATENT COOPERATION TREATY--CHAPTER II**

**PRELIMINARY AMENDMENT A
PRIOR TO ACTION**

APPLICANT(S): Yizhou Song, et al.
ATTORNEY DOCKET NO.: P05,0328
INTERNATIONAL APPLICATION NO: PCT/JP2004/007609
INTERNATIONAL FILING DATE: June 2, 2004
INVENTION: Thin Film Forming Method and Forming Device
Therefor

Mail Stop PCT
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants herewith amend the above-referenced PCT application, and request entry of the Amendment prior to examination on the United States Examination Phase.

Amendments to the Drawings are reflected in the Replacement Pages attached as an Appendix to this amendment and the appertaining comments on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims that begins on page 3 of this paper.

Remarks begin on page 6 of this paper.